

DOCKET NO.: 0039-7684-2SRDDIV/nhd

JAN 09 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

BY RE APPLICATION OF: Hisako AOYAMA, et al.

SERIAL NUMBER: 09/558,053

GROUP: 2823

FILED: April 26, 2000

EXAMINER: MALDONADO, Julio J

FOR: PROCESS FOR FABRICATING A METAL WIRING AND METAL CONTACT IN  
A SEMICONDUCTOR DEVICE

**REQUEST TO CORRECT TITLE OF INVENTION**

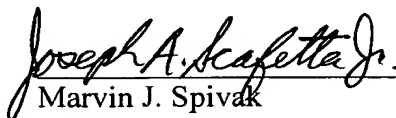
MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request  
correction of your records to reflect the correct title of the invention. The title of the  
invention should read as follows: **PROCESS FOR FABRICATING A METAL WIRING  
AND METAL CONTACT IN A SEMICONDUCTOR DEVICE.**

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

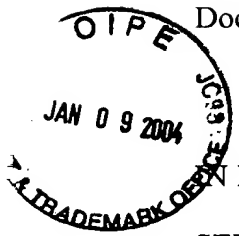


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(OSMMN 08/03)

Docket No.: 0039-7684-2SRDDIV/nhd



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

RE APPLICATION OF: Hisako AOYAMA, et al.

SERIAL NUMBER: 09/558,053

GROUP: 2823

FILED: April 26, 2000

EXAMINER: MALDONADO, Julio J

FOR: PROCESS FOR FABRICATING A METAL WIRING AND METAL CONTACT IN  
A SEMICONDUCTOR DEVICE

**REQUEST TO CORRECT FIRST INVENTOR'S NAME**

MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

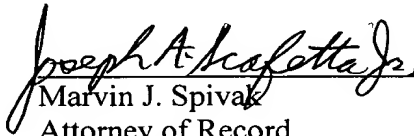
SIR:

In the matter of the above-identified application, we hereby request correction of your records to reflect the correct spelling of the first inventor's name.

The first inventor's name should be: **Hisako AOYAMA, et al.**

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

  
\_\_\_\_\_  
Marvin J. Spivak

Attorney of Record  
Registration No. 24,913  
**Joseph A. Scafetta, Jr.**  
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(OSMMN 08/03)



OSMM&N File No. 0039-7684-2SRD DIV

Dept.: E/M

By: EHK/CES/mai

Serial No. 09/558,053

In the matter of the Application of: Hisako AOYAMA, et al.

For: **PROCESS FOR FABRICATING A METAL WIRING AND METAL  
CONTACT IN A SEMICONDUCTOR DEVICE**

Due Date: N/A

The following has been received in the U.S. Patent Office on the date stamped hereon:

- Dep. Acct. Order Form
- Amendment Cover Letter
- Response under 37 CFR § 1.312

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